

We use these spectra to find out how much solar energy is absorbed by layers of varying thickness. The example used in the figure is an a-Si:H layer with a thickness  $d = 500$  nm. Such a layer absorbs essentially all photons with energies greater than 1.9 eV (the energy at which  $\alpha = 1/d$ ). We then look up how much solar irradiance lies above 1.9 eV. Assuming that the reflection of sunlight has been minimized, we find that about  $420 \text{ W/m}^2$  is absorbed by the layer (the gray area labeled “absorbed”). Through such a layer  $580 \text{ W/m}^2$  of energy is transmitted. These energies may be compared to the results for c-Si, for which a 500-nm-thick layer absorbs less than  $200 \text{ W/m}^2$ .

To absorb the same energy as the 500-nm a-Si:H layer, a c-Si layer needs to be much thicker. The implication is that much less material is required to make a solar cell from a-Si than from c-Si.<sup>3</sup> In the remainder of this section, we first describe how amorphous silicon solar cells are realized in practice, and we then briefly summarize some important aspects of their electrical characteristics.

## 12.1.2 Designs for Amorphous Silicon Solar Cells: A Guided Tour

Figure 12.1 illustrates the tremendous progress over the last 25 years in improving the efficiency of amorphous silicon-based solar cells. In this section we briefly introduce three basic ideas involved in contemporary, high-efficiency devices: (1) the *pin* photodiode structure, (2) the distinction between “substrate” and “superstrate” optical designs, and (3) multijunction photodiode structures. A good deal of this chapter is devoted to more detailed reviews of the implementation and importance of these concepts.

### 12.1.2.1 *pin* photodiodes

The fundamental photodiode inside an amorphous silicon-based solar cell has three layers deposited in either the *p-i-n* or the *n-i-p* sequence. The three layers are a very thin (typically 20 nm) *p*-type layer, a much thicker (typically a few hundred nanometer), undoped *intrinsic* (*i*) layer, and a very thin *n*-type layer. As illustrated in Figure 12.3, in this structure excess electrons are actually donated from the *n*-type layer to the *p*-type layer, leaving the layers positively and negatively charged (respectively), and creating a sizable “built-in” electric field (typically more than  $10^4 \text{ V/cm}$ ).

Sunlight enters the photodiode as a stream of photons that pass through the *p*-type layer, which is a nearly transparent “window” layer. The solar photons are mostly absorbed in the much thicker intrinsic layer; each photon that is absorbed will generate one electron and one hole photocarrier [12, 13]. The photocarriers are swept away by the built-in electric field to the *n*-type and *p*-type layers, respectively – thus generating solar electricity!

The use of a *pin* structure for a-Si:H-based solar cells is something of a departure from solar cell designs for other materials, which are often based on simpler *p-n* structures.

<sup>3</sup> The very different optical properties of c-Si and a-Si reflect the completely different nature of their electronic states. In solid-state physics textbooks, one learns about the “selection rules” that greatly reduce optical absorption in c-Si, which is an “indirect band gap” semiconductor. Such selection rules do not apply to a-Si. Additionally, the “band gap” of a-Si is considerably larger than that for c-Si.